

Docket: CU-3589

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application: Masahiro Sunohara et al.

] GRP ART UNIT: 2812

Serial No: 10/781,416

] Ex.:

Filed: February 18, 2004

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For: Semiconductor Device Fabrication Method

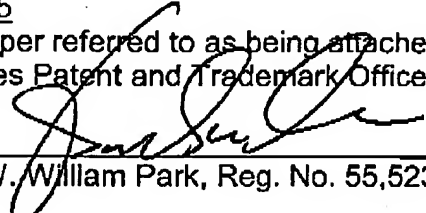
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**Certification under 37 C.F.R. §1.8(a)**

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted to the United States Patent and Trademark Office to the fax number and on the date indicated above.

  
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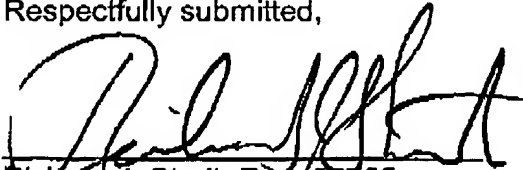
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**AUTHORIZATION TO ACT IN A REPRESENTATIVE CAPACITY**

The practitioner **Woochoon William Park, Reg. No. 55,523** is authorized to conduct interviews and has the authority to bind the principal concerned. Further, the practitioner is authorized to file correspondence in the above-identified application pursuant to 37 CFR 1.34, including to prosecute this application, to make alterations and amendments therein, to receive the patent, and to transact all business in the United States Patent & Trademark Office connected therewith.

The practitioner named above does not have the authority to sign a request to change the correspondence address, a request for an express abandonment, a disclaimer, a power of attorney, or other document requiring the signature of the applicant, assignee of the entire interest or an attorney of record. If appropriate a separate Power of Attorney to the above named practitioner should be executed and filed in the United States Patent and Trademark Office.

Respectfully submitted,

Dated: January 11, 2005  
Richard J. Streit, Reg. 25765  
Ladas & Parry  
224 South Michigan Avenue  
Chicago, Illinois 60604  
(312) 427-1300